Substitute for form 1449/PTO & 1449B/PTO

## FOURTH INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

	Complete if Known	7
Application Number	10/551,286	- APR 0 1 2010
Filing Date	July 6, 2006	17
First Named Inventor	Dieter Funk et a	1. / P
Examiner Name	Cynthia Szewcz	yk AADEMARY
Attorney Docket No.	1021500-00014	3

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Examiner Initials	Document Number- Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Figures Appear			
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	Name of Patentee or Applicant of Cited Document	Translation	Partial Translation	Eng. Lang. Summary	Office Actiont	IPER	Abstract		in Spec. / j. No(s).	
JP 2001-158631 A	06-12-2001	TAMAI, et al.				Х		Х		
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	Country Code <sup>1</sup> , Number, Kind Code	Foreign Patent Document  Country Code <sup>1</sup> , Number, Kind Code  Description Date (MM-DD-YYYY)  JP 2001-158631 A 06-12-2001	Foreign Patent Document  Country Code¹, Number, Kind Code  Document  Publication Date (MM-DD-YYYY)  JP 2001-158631 A  O6-12-2001  TAMAI, et al.	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Task at its process of the process	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  JP 2001-158631 A  06-12-2001  Tanslation Date (Document)  Name of Patentee or Applicant of Cited Document  Tanslation Date (MM-DD-YYYY)  Tanslation Date (MM-DD-YYYY)  Tanslation Date (MM-DD-YYYY)	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Name of Patentee or Applicant of Cited Document  Name of Patentee or Applicant of Cited Document  Tanslation  Partial  Tanslation  Partial  Tanslation  Partial  Tanslation  Partial  Tanslation  Tanslation  Partial  Tanslation  Partial  Tanslation  TAMAI, et al.	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Translation  Translation  Translation  Translation  Translation  Translation  Translation  Translation  Translation  X  X	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Applicant of Cited Document  Name of Patentee or Applicant of Cited Document  Translation  Translation  Action Per R  X  JP 2001-158631 A  06-12-2001  TAMAI, et al.  X	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Name of Patentee or Applicant of Cited Document  Name of Patentee or Applicant of Cited Document  Translation  Translation  Translation  X  X  X	Foreign Patent Document  Country Code¹, Number, Kind Code  Publication Date (MM-DD-YYYY)  Publication Date (MM-DD-YYYY)  Applicant of Cited Document  Document  STATUS  STATUS  Cited Partial  JP 2001-158631 A  06-12-2001  TAMAI, et al.  STATUS  Cited Partial  Action  R  X  X  X

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Examiner Signature	/Cynthia Szewczyk/	Date Considered	08/23/2010	
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